



SHINICHI KURITA

*Appointed Vice President
Head of Thin Film Engineering
Display and Flexible Technology Group
Applied Materials Fellow*

Shinichi Kurita is appointed vice president and head of thin film engineering for the Display and Flexible Technology Business Group. He leads a global team of hardware and software engineers in the U.S., Germany, Korea, Taiwan, Japan and India—all focused on rapidly developing innovative new products at a time when the opportunities for Applied's Display technology are expanding quickly.

Mr. Kurita is widely recognized in the display industry as an innovation leader in CVD, with extensive experience in new product development and systems design engineering. As part of Applied's Display and Flexible Technology group for over two decades, he has held engineering and management positions of increasing responsibility, working on the development of new CVD systems from Gen 2 up to today's Gen 10+, as well as PVD and Evaporation systems.

The products that his team has developed have generated over \$10 billion in revenue for the company. In 2013, his many profitable contributions to Applied Materials' product portfolio were recognized when he was named an Applied Materials Fellow.

Prior to Applied, Mr. Kurita was responsible for mechanical electrical system engineering at Hitachi Ltd. in Japan, where he developed automated plasma welding equipment for gas lines, inspection robots for small diameter pipelines and gas tanks, and large size induction motors for power plants.

Mr. Kurita has been awarded more than [392 worldwide](#) patents and over [102 U.S.](#) patents, including [30](#) as first inventor and four as sole inventor. He has authored numerous papers on welding technology and piping equipment. He holds a bachelor of science degree in Mechanical Engineering from the Tokyo University of Science.